

PATENT ASSIGNMENT

Electronic Version v1.1

Stylesheet Version v1.1

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT
CONVEYING PARTY DATA	
Name	Execution Date
Industrial Technology Research Institute	06/01/2008
RECEIVING PARTY DATA	
Name:	Etron Technology Inc.
Street Address:	No. 6, Technology Road 5, Hsinchu Science Park
City:	Hsinchu
State/Country:	TAIWAN
Postal Code:	30078
PROPERTY NUMBERS Total: 3	
Property Type	Number
Patent Number:	5429714
Patent Number:	5395784
Patent Number:	5338750
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Total Attachments: 1 source=SKMBT_50008080715302#page1.tif	

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PATENT
REEL: 021339 FRAME: 0909

ASSIGNMENT OF PATENT

Atty Dkt No.:

WHEREAS, **Industrial Technology Research Institute**, of Hsinchu, Taiwan, whose address is No. 195, Sec. 4, Chung Hsing Rd., Chutung, Hsinchu, Taiwan, 310, R.O.C. and **ETRON TECHNOLOGY INC**, of Hsinchu, Taiwan, whose address is No. 6, Technology Road 5, Hsinchu Science Park, Hsinchu, Taiwan 30078, R. O. C., both of them are the co-owners of the entire right, title and interest of the following U.S. Patent(s):

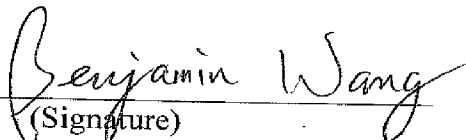
<u>Patent No.</u>	<u>Title</u>
5,429,714	Fabrication Method to Produce Pit-Free Polysilicon Buffer local oxidation Isolation
5,395,784	Method of Manufacturing Low Leakage and Long Retention Time Dram
5,338,750	Fabrication Method to Produce Pit-Free Polysilicon Buffer Local Oxidation Isolation

WHEREAS, **Industrial Technology Research Institute**, of Hsinchu, Taiwan, whose address is No. 195, Sec. 4, Chung Hsing Rd., Chutung, Hsinchu, Taiwan, 310, R.O.C., hereinafter referred to as "assignee", is desirous of acquiring the entire right, title and interest in the same;

NOW, THEREFORE, for good and valuable consideration, the receipt whereof is acknowledged, we, the patent owners, by these presents do sell, assign and transfer unto said assignee the entire right, title and interest in and to the aforementioned Patents; the same to be held and enjoyed by the said assignee for his own use and behoof, and for his legal representatives and assigns, to the full end of the term for which said Patents is granted, as fully and entirely as the same would have been held by me had this assignment and sale not been made.

Executed this 1st day of June, 2008, at Hsinchu.

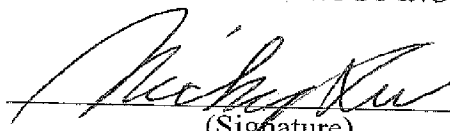
Industrial Technology Research Institute


(Signature)

Benjamin WANG

General Director
(Title)

ETRON TECHNOLOGY INC


(Signature)

Nicky Lu

President
(Title)